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Application Number	10/617,321
Filing Date	07/10/2003
First Named Inventor	Choi et al.
Group Art Unit	2834
Examiner Name	Unassigned <i>T. Dougherty</i>
Attorney Docket Number	PA88/UTS-39-05D09

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Sheet	1	of	2
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Examiner: Thomas M. Dougherty Date: July 29, 2004
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Feldman et al., "Wafer Chuck for Magnification correction in X-ray Lithography," *Journal of Vacuum Science and Technology*, Nov/Dec 1998, pp. 3476-3479, vol. B 16(6).

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Date
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